

Article

Correlation between the Dimensions and Piezoelectric Properties of ZnO Nanowires Grown by PLI-MOCVD with Different Flow Rates

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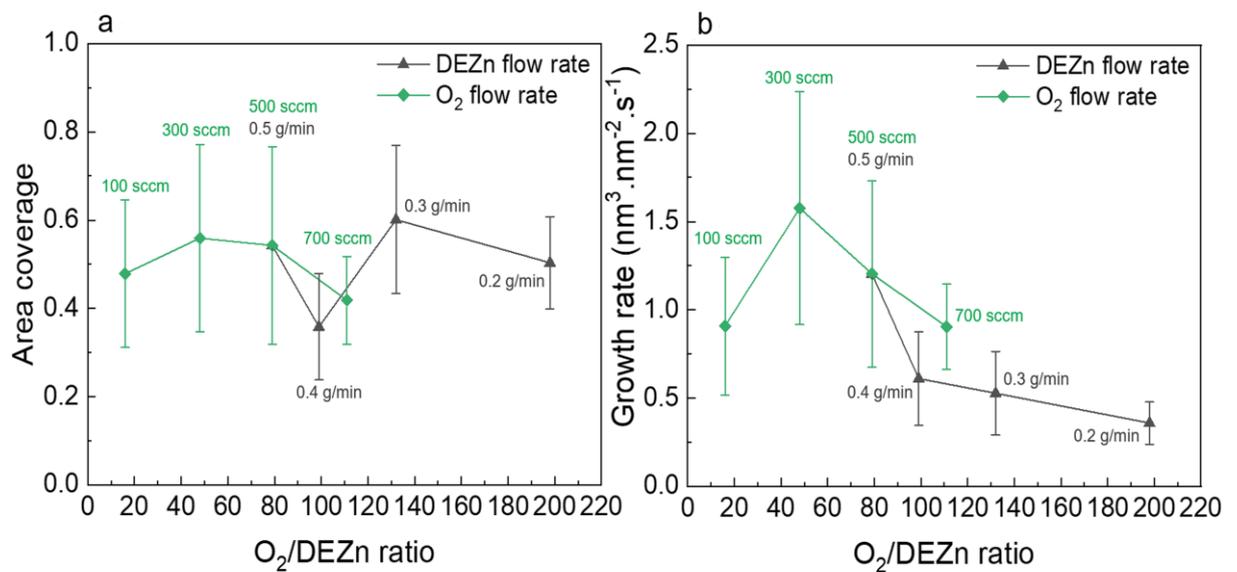


Figure S1. Evolution of (a) the coverage area and (b) the growth rate (volume per nm²/s, or nm³.nm⁻².s⁻¹) of NW arrays as a function of the O₂/DEZn flow rate ratio.

To simplify, we assume the NW section as being a cylindrical shape, then the growth rate can be calculated as follows:

$$growth\ rate_{(volume\ per\ nm^2 / growth\ time)} = \frac{l \times \pi r^2 \times density}{t} \quad (S1)$$

where l is the NW length, r is the NW radius (half of diameter), t is the growth time, and density is the number of NW per nm² (the unit of density is converted from NWs/cm² to NWs/nm² for this calculation). In this equation, $(\pi r^2 \times density)$ is the defined as the area coverage of the NW array:

$$Area\ coverage = \pi r^2 \times density \quad (S2)$$

In other words, the area coverage is the total area of NWs per nm^2 . Since there are voids between NWs, the area coverage values of NW samples are less than 1. In case of the thin film, the area coverage value is equal to 1 as there is no void, hence the equation (S1) becomes the film thickness/growth time ratio and is equivalent to the growth rate for a 2D layer.

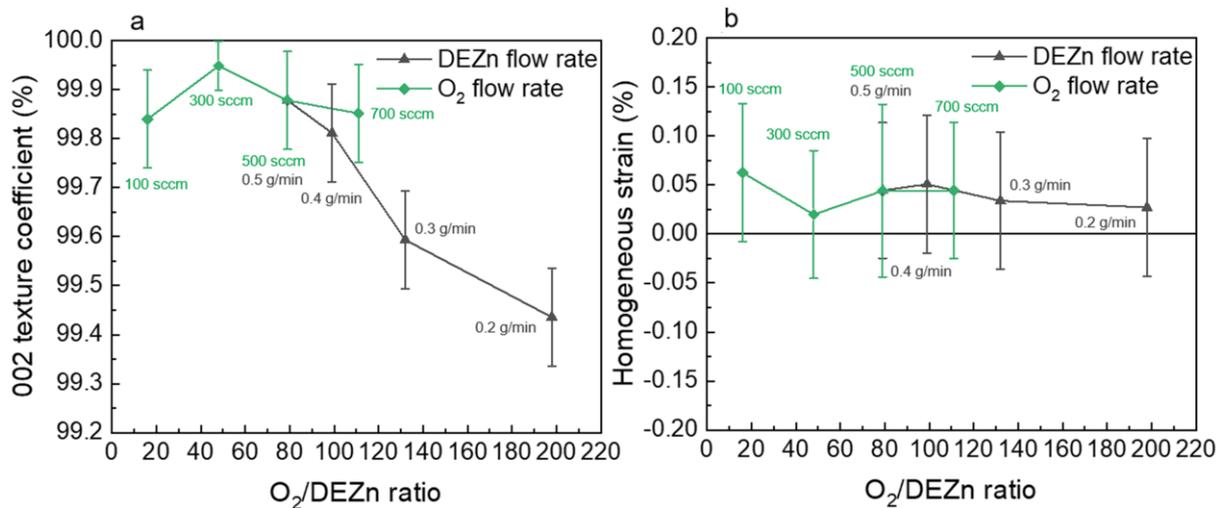


Figure S2. Evolution of (a) the 002 texture coefficients and (b) the residual homogeneous strains of NW arrays as a function of the O_2/DEZn flow rate ratio.

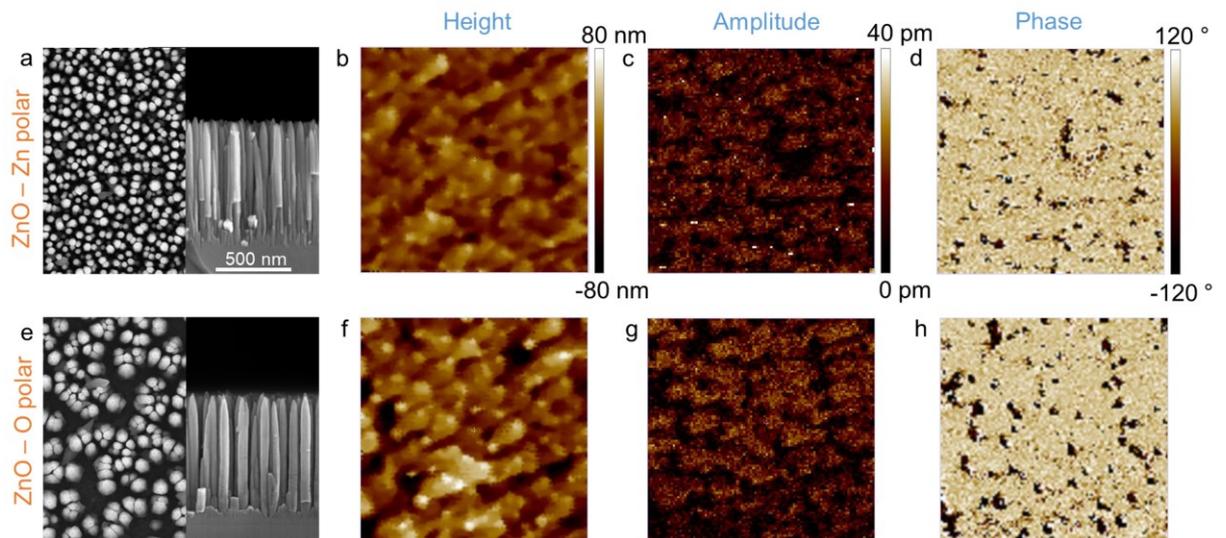


Figure S3. Top-view (left) and cross-sectional-view (right) FESEM images of ZnO NW arrays grown on (a) Zn-, and (e) O-polar ZnO substrates. PFM scanning images of ZnO NW arrays grown on (b-d) Zn-, and (f-h) O-polar ZnO substrates.

Figure S3 presents the FESEM images and PFM maps of ZnO NW arrays on ZnO substrates after the growth for 7 minutes. The FESEM images (Figures S3a and e) display the well-aligned ZnO NW arrays formed on the Zn- and O-polar ZnO substrates. The NW length is similar between the two arrays and around 870 nm. However, it can be seen that the NWs grown on the Zn-polar ZnO substrate have a smaller diameter and a higher density as compared to the NWs grown on the O-polar ZnO substrate. In detail, the diameters of NWs on the Zn- and O-polar ZnO substrates are around 49 and 53 nm, re-

spectively. The density of NW array on the Zn-polar ZnO substrate is around 25×10^9 NWs/cm², while it is 12×10^9 NWs/cm² on the O-polar ZnO substrate.